

IEEE SW Test Workshop
Semiconductor Wafer Test Workshop



Expanding Test Coverage at Sort to Reduce Overall Product Costs

FormFactor

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Agenda

- **Product Studies**
- **Card Attributes/Life Study**
- **Cost of Ownership**
- **Next Steps**
- **Summary**



Product Studies

- **Probe Head specification vs. Cantilever**
- **High speed product evaluation**
 - 1.6GHz
 - Al pads
- **Power management evaluation**
 - 1.5 Amps
 - Copper pads
- **1st Production Version**
 - Beat production schedule



MEMS vs. Cantilever Probe Specifications

MEMS Specification

- **Probe Inductance 1.1 to 1.3nh**
 - Typical Probe 2.4mm in length
- **Planarity +-10um**
 - Actual part +/-5 um
- **Probe life >1million**
- **Controlled Z probe launch**
- **Passive Components mount on Probe Head**
- **Current carrying capability 0.5A**
 - Actual 1.5A on 2 probes

Cantilever Specification

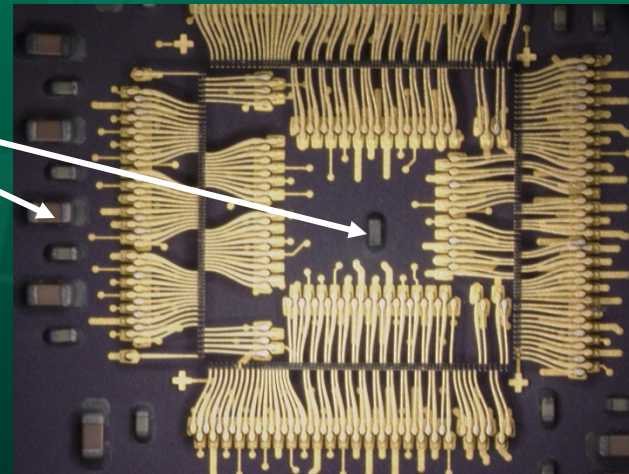
- **Probe Inductance 27nh / inch**
 - Typical Probe 1 inch in length
- **Planarity +-15um**
- **Probe life ~1million**
- **Controlled Z to PCB Launch**
- **Passive Components on PCB**
- **Current carrying capability 200mA with 25um tip**



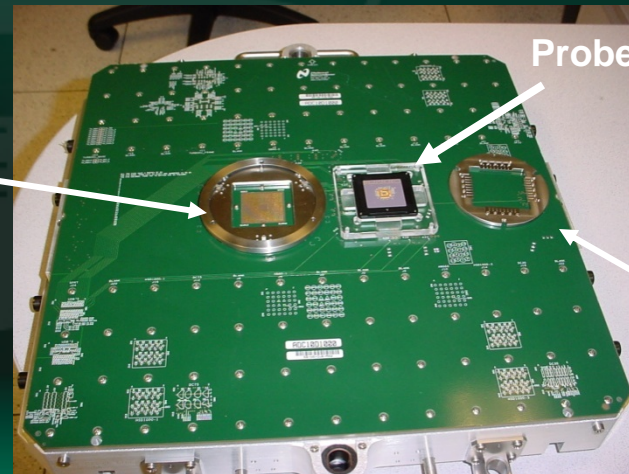
High Speed Probe Head Hardware

- **Critical Passives on Probe Head**
 - 48 components on ADC PH
- **78 Matched transmission line length on Probe Head**
 - Includes probe length
 - Used PCB to compensate groups
- **EZ to assemble and exchange probe head**
 - Mechanical Assembly
 - Probe Head
 - PH Cover
- **760 Pin I/O**

Probe Array



ADC / FormFactor DIB



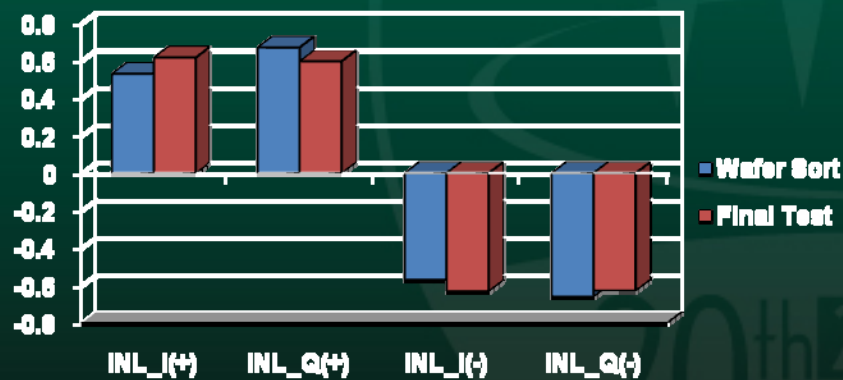
Probe Head (PH)

PH Cover

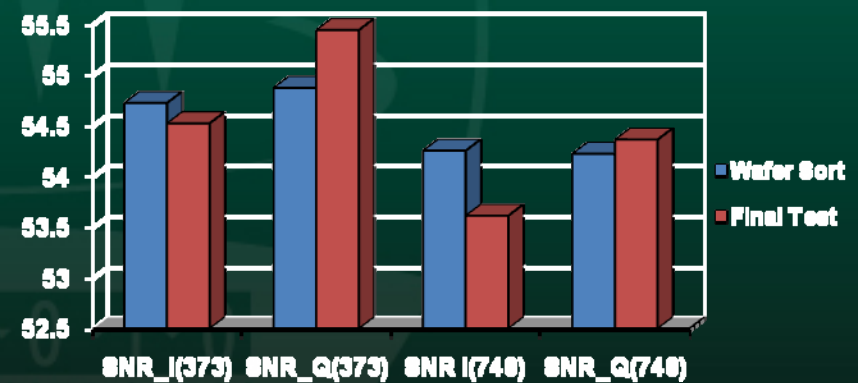


Good Correlation Between Sort and Final Test

Linearity Test Results



Dynamic Test Results with Input Frequency

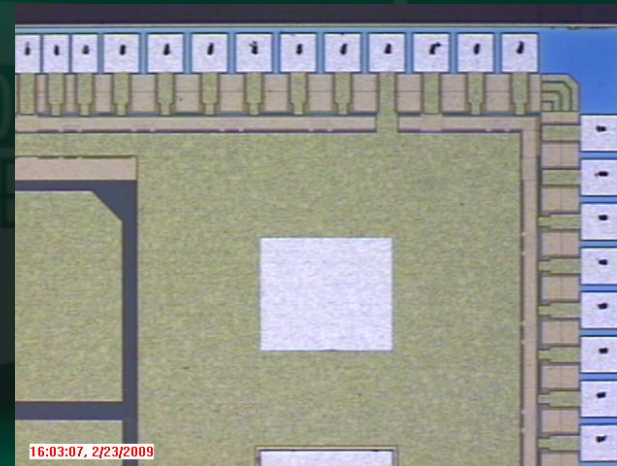
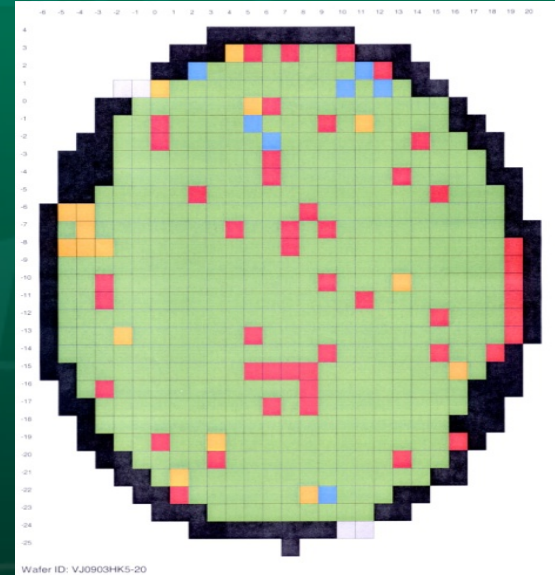


Not able to run these tests with Cantilever card



High Frequency Product Probe Card Test Results

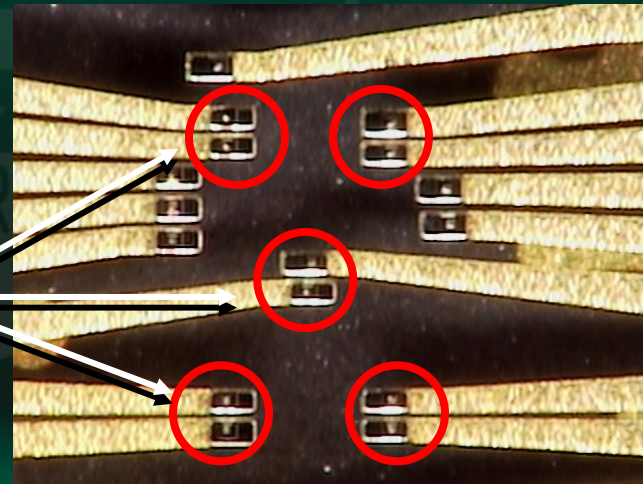
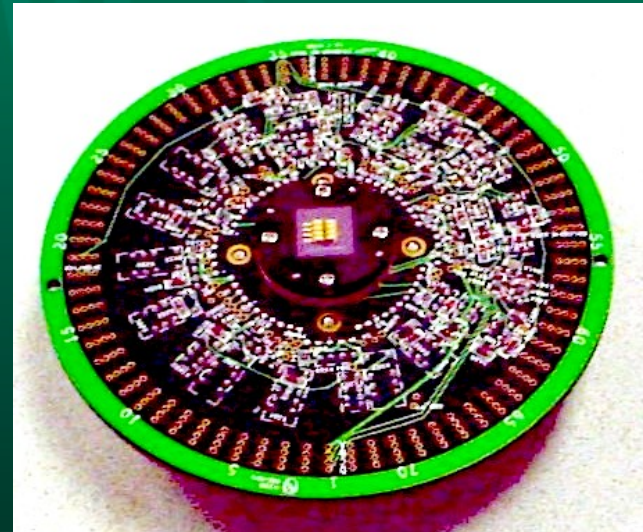
- **Test Vehicle: High frequency AL pads**
 - Sampling rate 1.6 Gbps .
 - AC test input frequency
 - 250 and 750M.
- **Compared to currently released wafer sort solution**
 - Tests only continuity, voltage level and power supply current; no AC tests.
 - ~Equivalent yield.
- **Yield on MEMS probe card**
 - Equivalent yield Compared to Cantilever Test List
 - SNR and Linearity yield at Sort at 6%
 - Compared SNR and Linearity test at to FT results
 - ~6% yield loss due to AC test failures (SNR and Linearity)



Power Management Device

Probe Assembly as Tested

- Compact Design
- Kelvin on 5 pins
- Components on probe head
- 136 I/O connections
- Good contact on Copper Pads
- EZ setup / EZ replacement
- Can have multiple force pins
 - 2 for and one sense pin on 180 x 68 um pad
- Probe Head Configurable
 - Multi Site

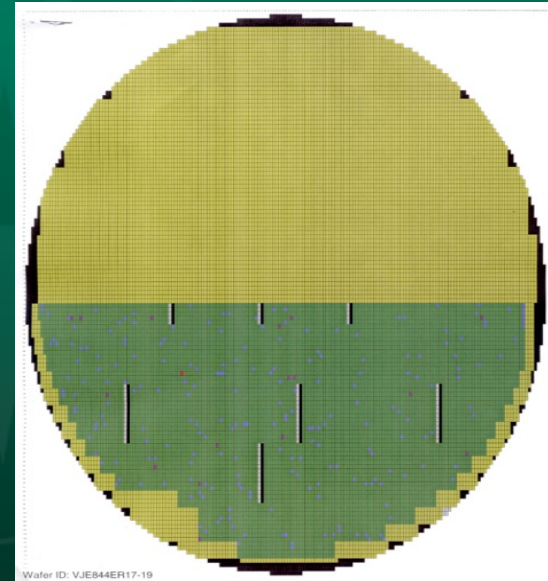


Kelvin Pins



Test Results on Power Management Device

- Single Wafer Sorted 8 times
- No probe pad damage on Copper
- Continuity stable
- RDSON Stable
- I_limit Stable
 - Tests up to 1.5amps with two force pins



DATE 1/8/2009
LOT# VJE844ER10 to WJE844ER17
Wafer 19
Sort Bottom half wafer, 8 times
Temperature Room
PCB Modified kelvin
Product File Mofidied to not touching edge dies

	Bin 1 (%)
VJE844ER10	96.92
VJE844ER11	96.75
VJE844ER12	96.85
VJE844ER13	96.88
VJE844ER14	96.85
VJE844ER15	96.99
VJE844ER16	96.94
VJE844ER17	96.81

Note There is no strip issue on all 8 sorts.



Summary Initial Product Trials

- **Sort Improvements using MEMS Probes**

- Better signal fidelity at die
 - Bypass, bias resistors, inductors, short probes, etc.
- We can effectively test everything at wafer sort on both ADC and PM devices
- Improved probe card life
- Reduce scrap after value added steps

- **Tradeoffs**

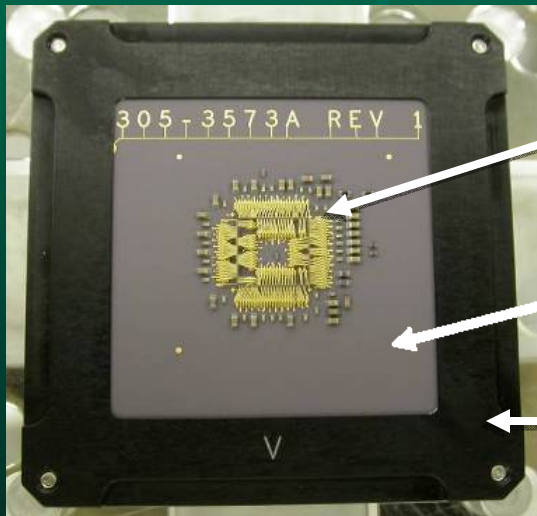
- Longer lead time for MEMs card
 - Ceramic lead time
- Initial cost higher



Card Attributes/Life Studies



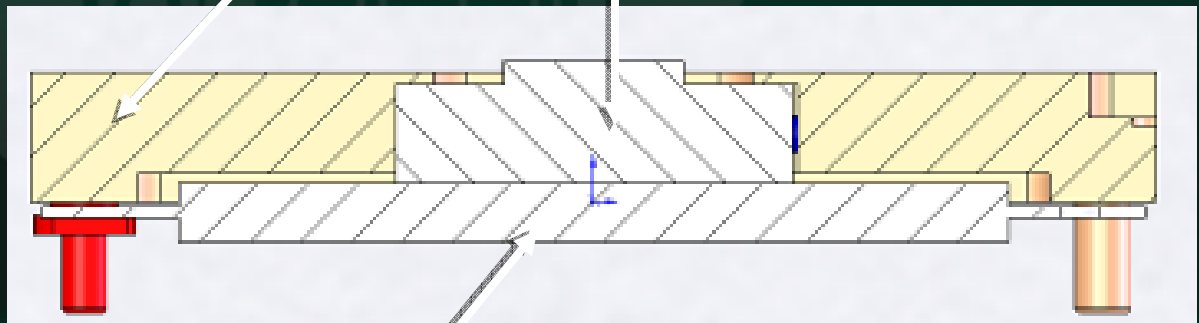
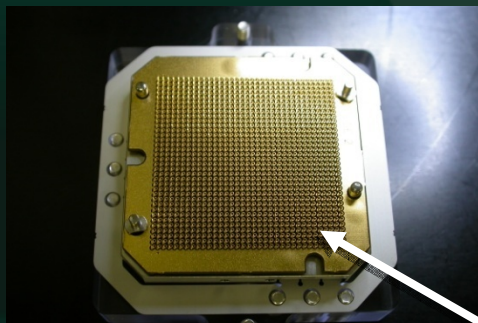
Product Supplied as an Insert Large Version with 780 LGA Points



MEMs Springs

Probe Head (PH)

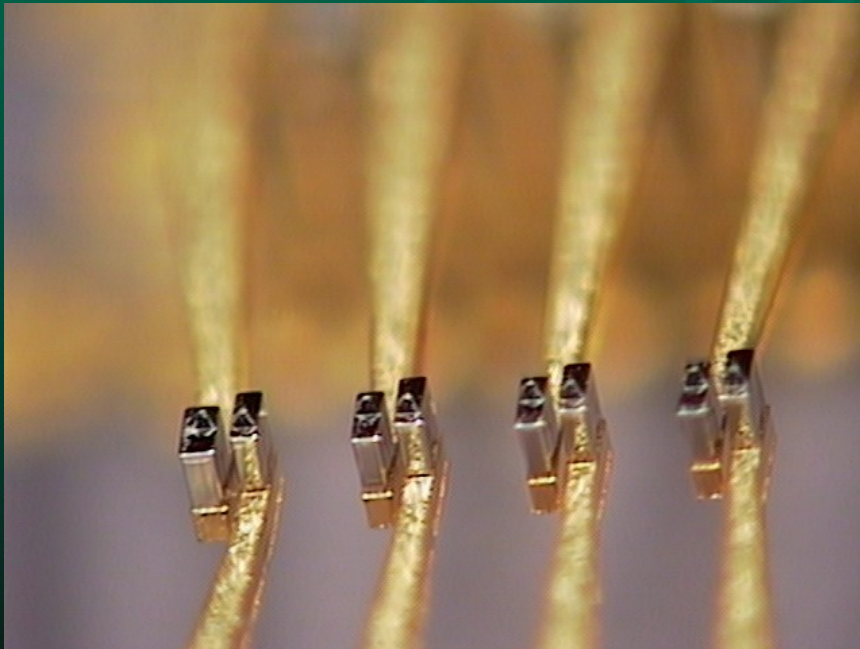
PH Frame



Interposer



CRES Test Probes Setup Criteria



- **Probe Tip 20um**
- **Probe Force 1.2g/mil**
 - Meets SUP (Structure Under Pad) specification
- **Over travel 1 to 4 mils Max**
- **Tested OT 2 and 3 mils**
 - Optimum CRES at 3 mils
- **Single touchdown**

MEMS Low Probe Force

Spring Force vs. Deflection

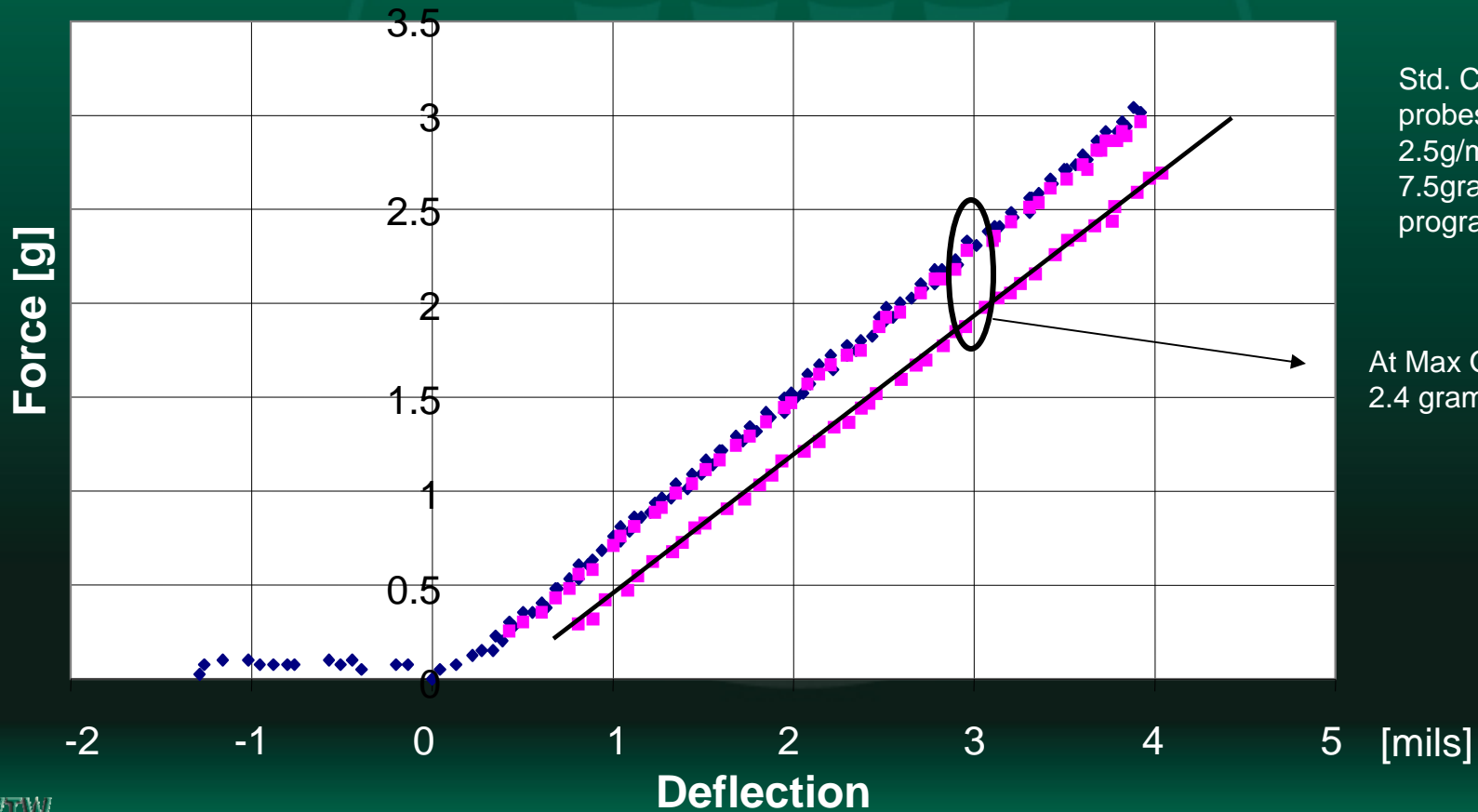
Actual part data

$$y = 0.7888x - 0.1113$$

$$R^2 = 0.9988$$

$$K = 0.7888 \text{ g/mil,}$$

$$Z\text{-Intercept} = (-)0.141 \text{ mil}$$

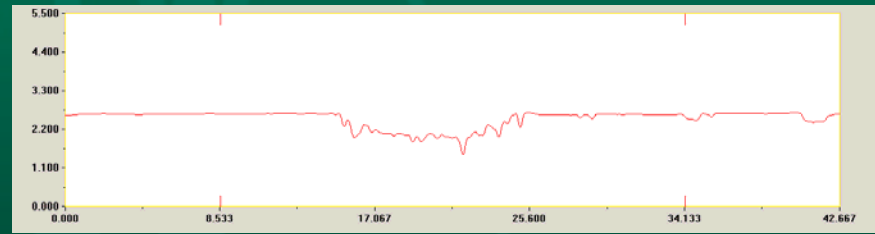
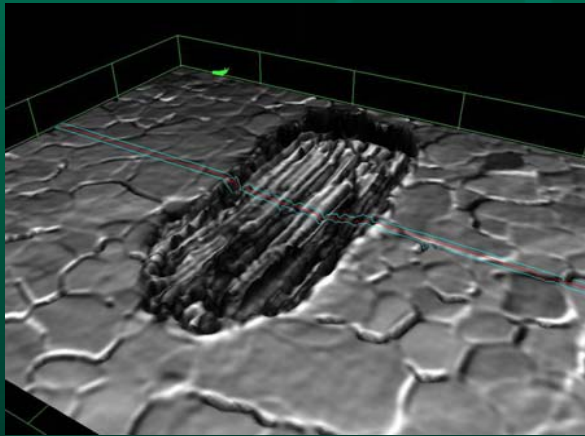


Std. Cantilever probes are 2.5g/mil OD or 7.5grams at program OD

At Max OD force = 2.4 grams



Typical 3D Image, Line Profile (center die) and Measurements (all)



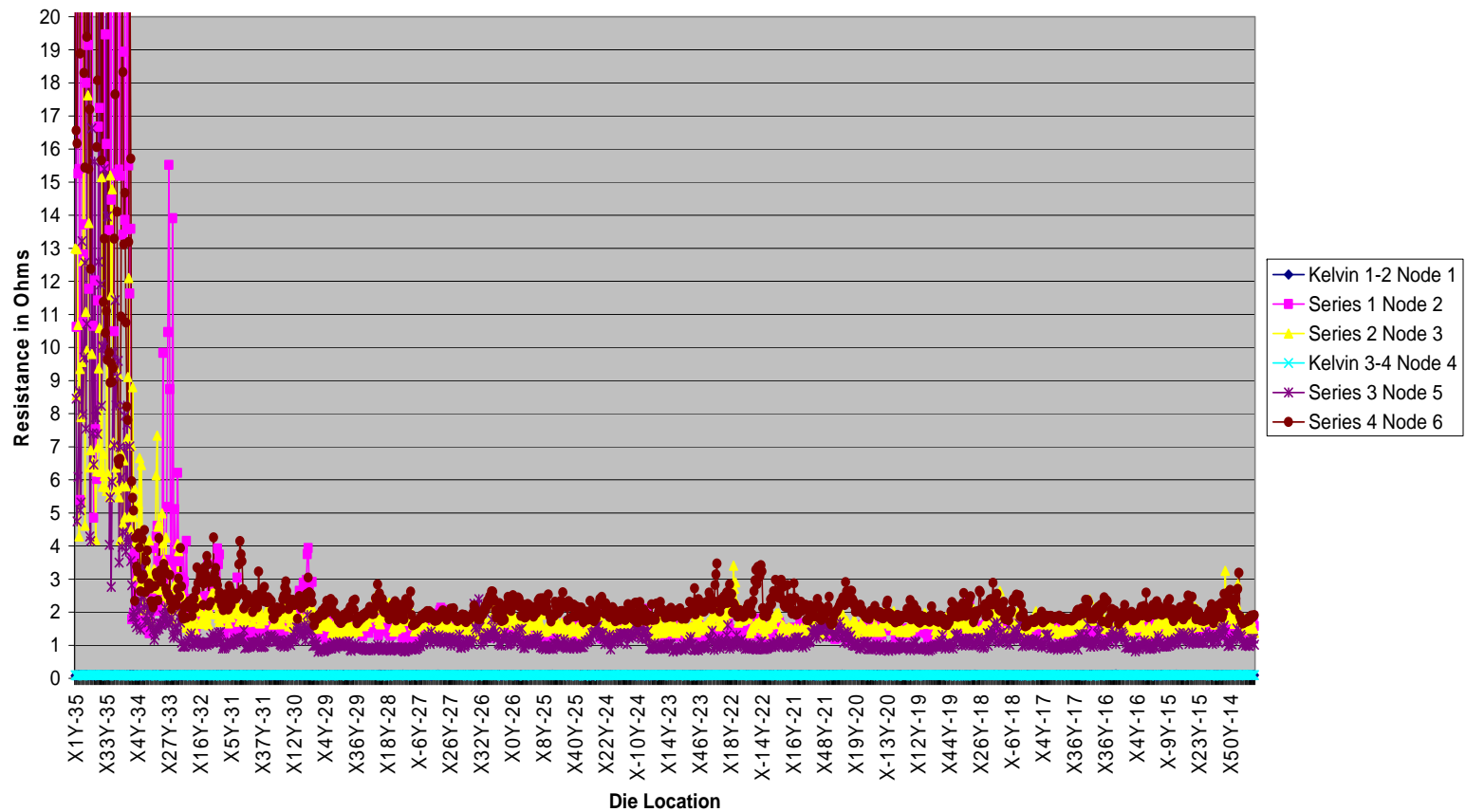
Total Average = 0.78 μ m (0.0308mils)

	top right	top left	top	right	left	center	bot right	bot left	bot
Average	0.74	0.6927	0.891 2	0.8438	0.7687	0.703	0.7082	0.804	0.8683
Max.	1.145	0.778	1.169	0.974	0.932	1.126	0.948	0.963	1.121
Min.	0.562	0.573	0.494	0.68	0.624	0.573	0.493	0.646	0.689
Range	0.583	0.205	0.675	0.294	0.308	0.553	0.455	0.317	0.432
Sigma	0.218	0.0724	0.222 4	0.1261	0.1105	0.2112	0.1535	0.1271	0.1713
3 Sigma	0.6541	0.2173	0.667 1	0.3782	0.3316	0.6336	0.4605	0.3813	0.514



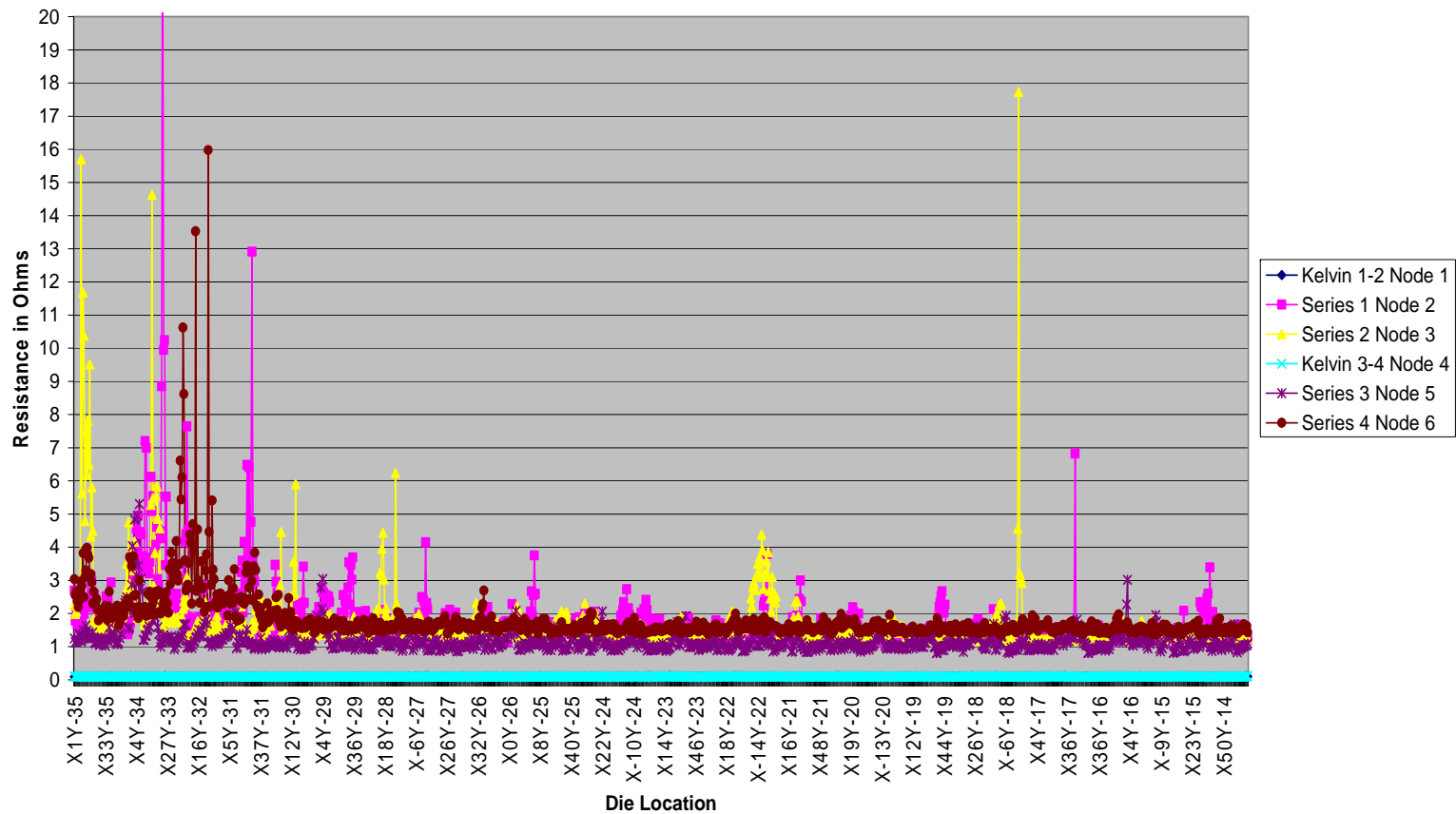
Optimizing CRES, with Cleaning and OT

Form Factor PROBE CARD
Al Plating Wafer
2 mil OT 1st 50 die, then 2.5 mil OT next 150 die, Remainder 3 mil OT
Cleaning every 200 Cycle, 25 Z only



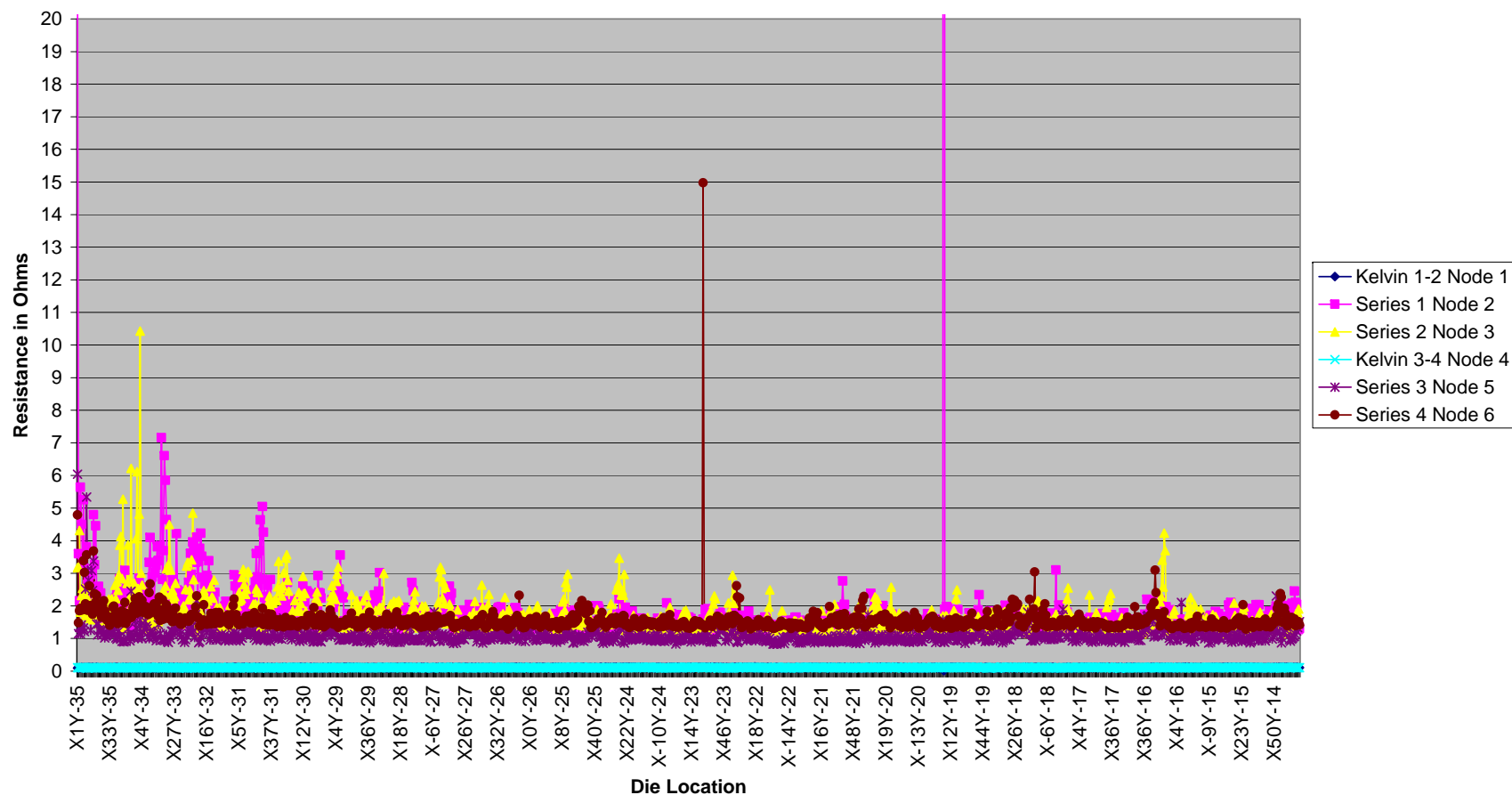
CRES with Optimized Cleaning and OT

Form Factor PROBE CARD
Al Plating Wafer
3 mil OT, cleaning 200 die iterations with 3 mils OT
Note: new pad



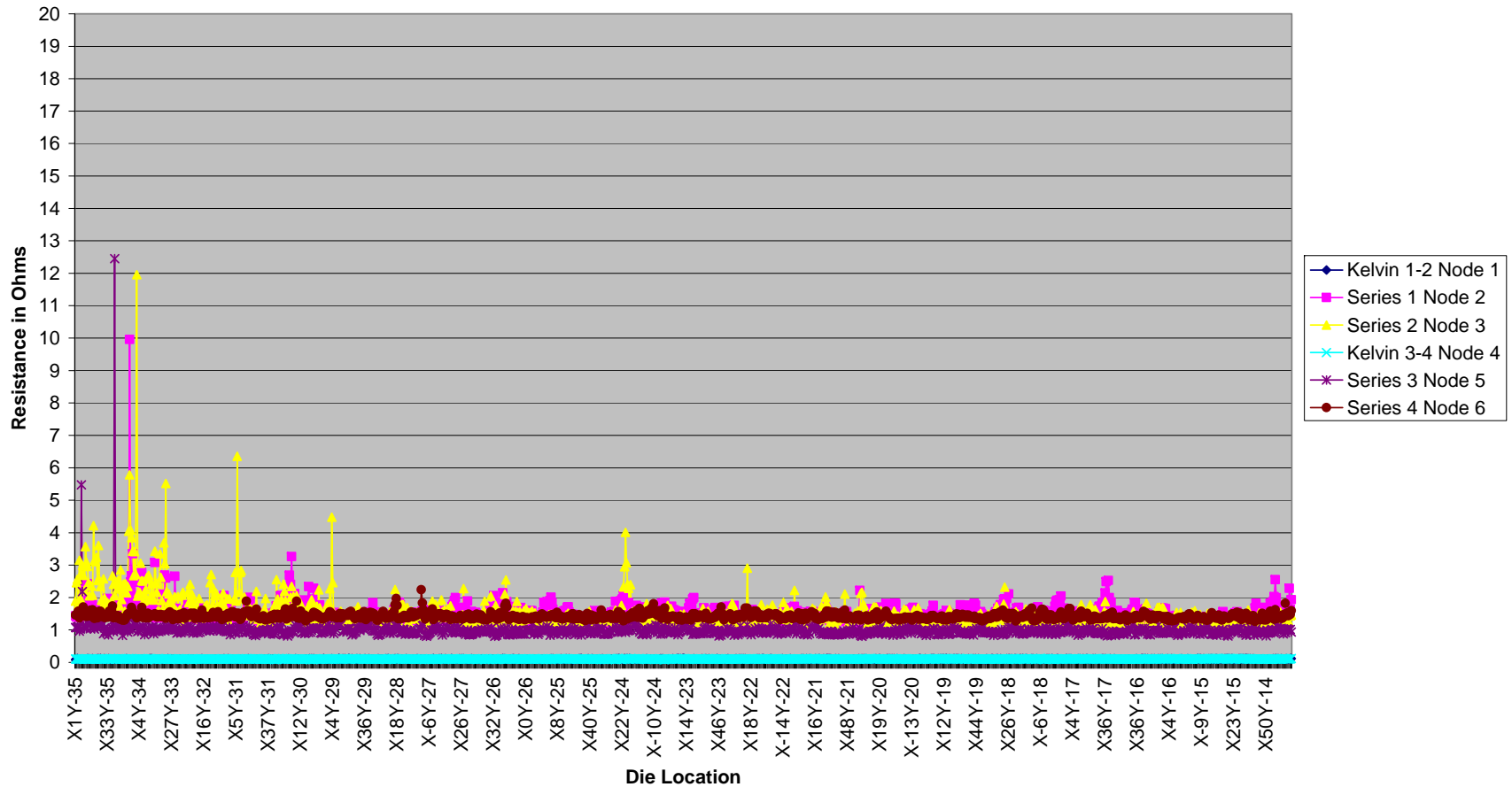
MEMS CRES after 100k + Insertions

Form Factor PROBE CARD
Al Plating Wafer
3 mil OD After 100k Insertions



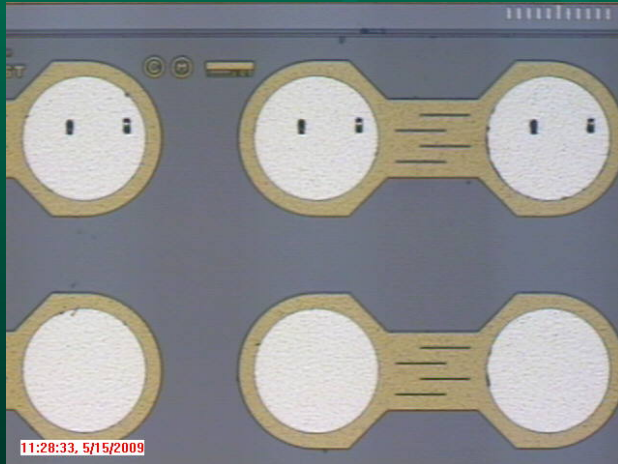
MEMS After 300k Insertions

Form Factor PROBE CARD with 300k Insertions
Al Plating Wafer
3 mil OD

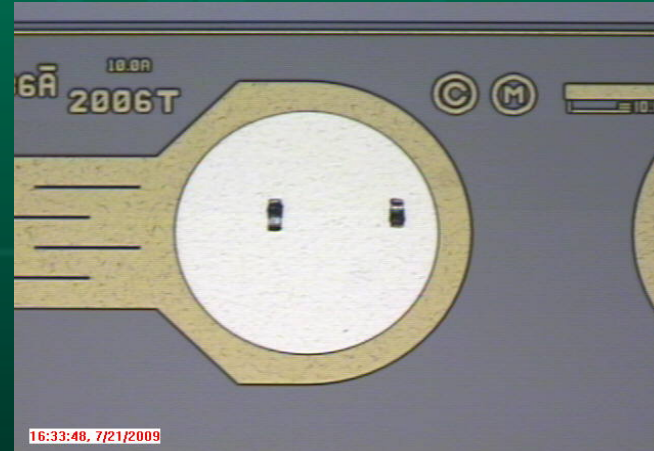


MEMS Probe Marks

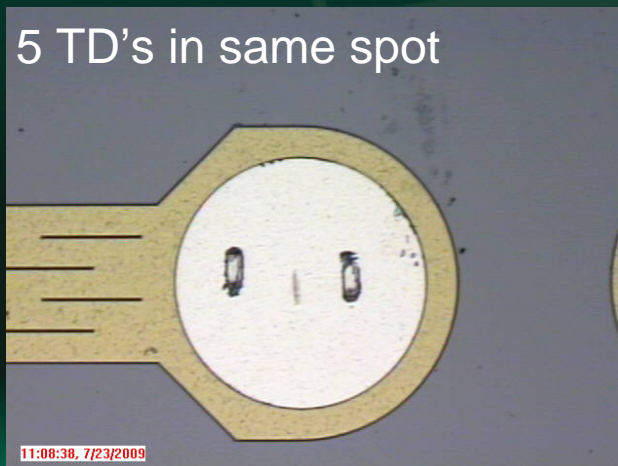
New Card



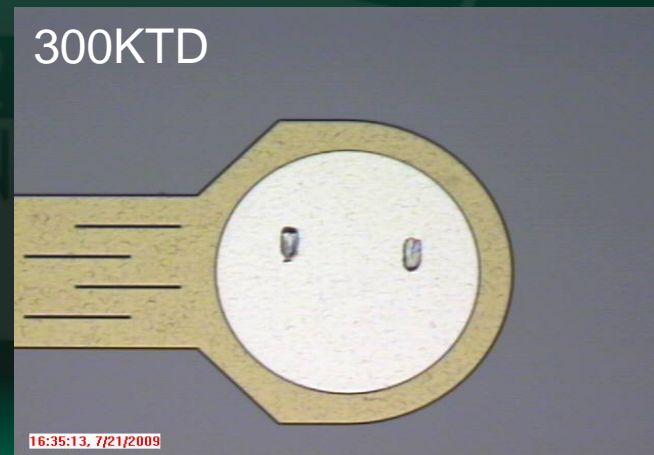
100K TD



5 TD's in same spot

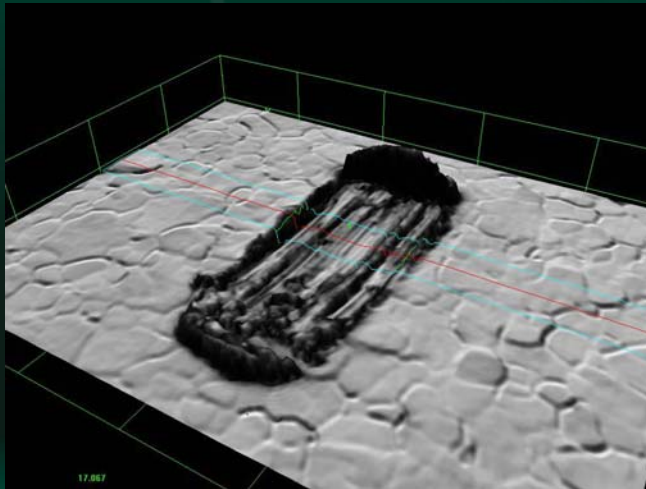


300KTD



MEMS Life Test

- Probe card life test through 375k insertions
- Cres Stable through 375k insertions
- Probe card wear minimal



Cost Of Ownership



Key Ideas for Cost Model

- Drive more test to wafer sort to yield at lower cost point
- Shmoo Volume, Package Cost, and yield variance to cantilever sort to determine value proposition



Key Cost Drivers

- **Sort Yield**
 - Test Everything at Wafer Sort
- **Final Yield**
 - Reduce Cost of Test at Final
- **Package Cost**
 - Reduce Package Scrap
- **Test Costs**
 - Sort typically costs less than FT



Cost Model for Power Management

5% better overall yield at Final Test

10 Total Program Wafers
 400 Die per Wafer
 400 TD's wafer (3X3mm die, 3000 dpw, 1//)
 1000000 Card Life FFI
 1000000 Card Life Cantilever
 2 Peak Card Usage

<u>Probe Card Costs</u>			<u>Test Cell Efficiency</u>			<u>Yield Benefit</u>		
	<u>Cantilever</u>	<u>FFI</u>		<u>Cantilever</u>	<u>FFI</u>		<u>Cantilever</u>	<u>FFI</u>
Initial PCB Cost	3000	3000	Total Program Wafers	10	10	Wafer Yield		
NRE	150	3500	Sort Steps	1	1	Wafer Cost	\$ 726	\$ 726
Spider/PH	1300	5000	Touch Down's/Wafer	400	400	Avg Yield	100%	89%
Cards Needed ¹	2	2	Avg Tech & Eng Labor	25	25	Program Wafers	10	10
Initial Card Cost	2750	13500	Test Cell Cost/sec	0.01	0.01	Yield Advantage		0
# Rebuilds	0	0	Total Program TD's	4,000	4,000	Yielded Die	4,000	3,560
Cost/Rebuild	1300	3000	On-Line Clean Cycle	100	100	Effective Wafer Yielded		-11%
Rebuild Cost	0	0	On-Line Clean Time	10	10	Yield Loss \$'s	\$ -	\$ (79.86)
# Repairs	5	2	Total On-Line Clean \$	4	4	FT Yield		
Avg. Repair Cost	500	1000	MTTA	25000	25000	FT Yield Loss	25.0%	9%
Repair Cost	2500	2000	Response Time (min)	15	15	Yield Loss	1,000	320
			Test Cell Wait Cost	1.44	1.44	Test Cost/Unit + Die Cost	235.56	235.56
			Off-Line Maint Freq	100000	100000	Pckg cost/Unit	37.20	37.20
			Avg Off-Line Cost	20	20	Cost of Scrap	\$272,760	\$87,392
			Cost of Off-Line Maint	0.8	0.8	Total Cost of good units	818280	883633.296
Total Cost of Scrap	\$5,250	\$15,500		\$6	\$6		\$272,760	\$87,312
Cost Benefit using FFI		(\$15,500)			\$0			\$185,448
Total Benefit/(Cost) of FFI vs. Other								\$169,948



Cost Model for ADC

TDs Wafer	3000
Sort Steps	1
Total TD/Wafer	3000
Card Life FFI	1000000
Card Life Other	500000
Peak Card	
Usage	2

Received a \$132K cost benefit by switching to MEMS

Probe Card Costs

<u>Cantilever</u>	<u>FFI</u>	
\$3,000	\$3,500	Initial PCB Cost
\$150	\$3,500	NRE
\$1,300	\$5,000	Spider/PH
2	2	Cards Needed ¹
\$5,750	\$17,000	Initial Card Cost
6	2	# Rebuilds
\$1,300	\$5,000	Cost/Rebuild
\$7,800	\$10,000	Rebuild Cost
5	2	# Repairs
\$500	\$1,000	Avg. Repair Cost
\$2,500	\$2,000	Repair Cost
\$16,050	\$29,000	Total Probe Card Spend

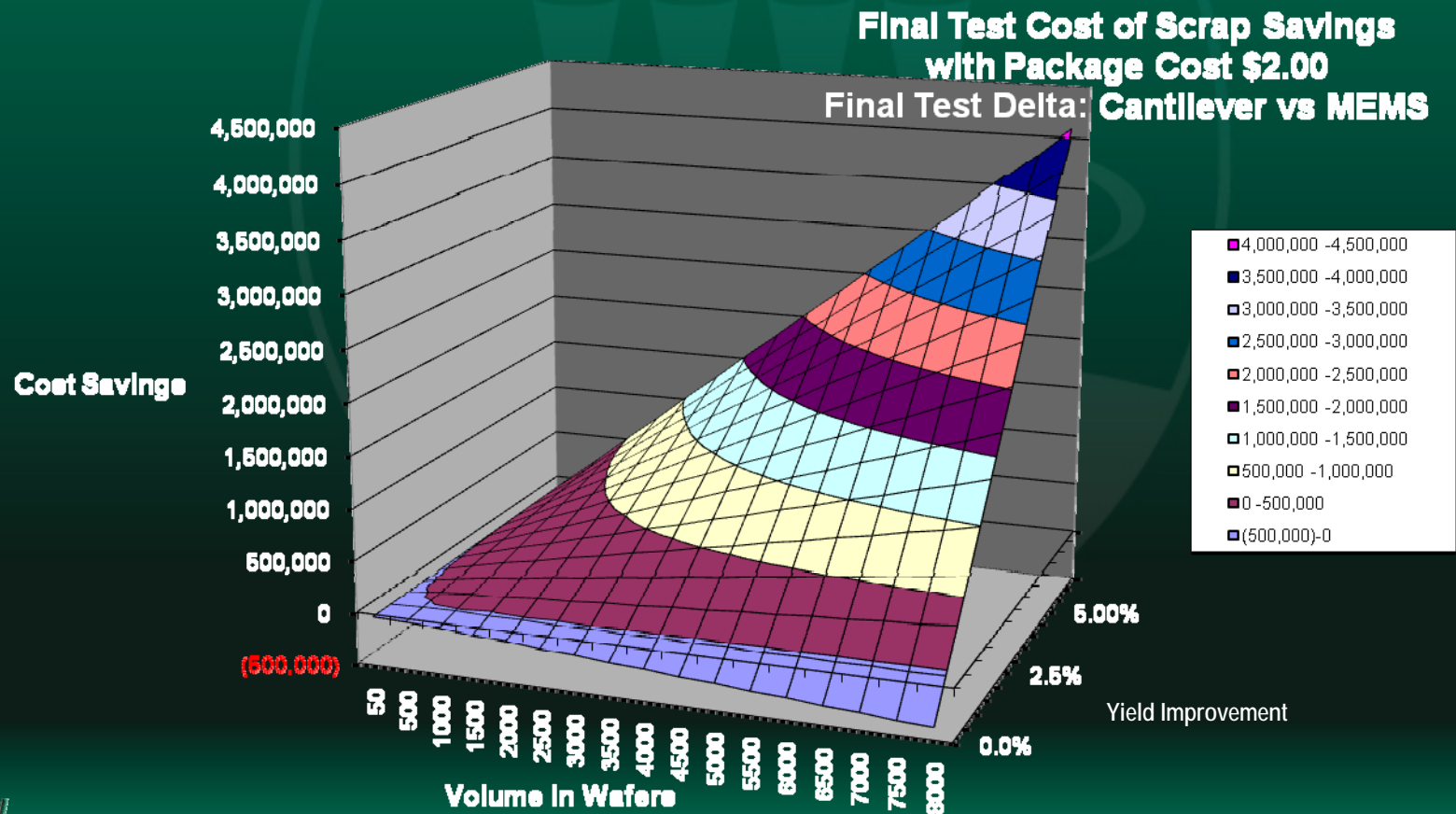
Yield Benefit

<u>Cantilever</u>	<u>FFI</u>	
1,500	1,500	Wafer Yield
3,000	3,000	Wafer Cost
98.0%	98.0%	Die Per Wafer
0.0%	2.0%	Base Wafer Yield
98.0%	96.0%	Underkill Identified at Sort
1,200	1,200	Final Sort Yield
3,528,000	3,456,000	Program Wafers
\$36,000	\$72,000	Yielded Die
		Cost of Yield Loss
2.0%		FT Yield
96.0%	98.0%	Underkill Passed on from Sort
141,120	69,120	Final Sort Yield
\$0.42	\$0.42	Pkg Part Loss
\$0.10	\$0.10	Final Test Cost
\$2.00	\$2.00	Package Cost
\$355,622	\$174,182	Die Cost
		Cost of Scrap
\$391,622	\$246,182	Cost of Yield Loss
\$407,672	\$275,182	Yield Loss + Probe Card Spend
	\$132,490	(Cost)/Benefit of MeMs



Cost Model for ADC

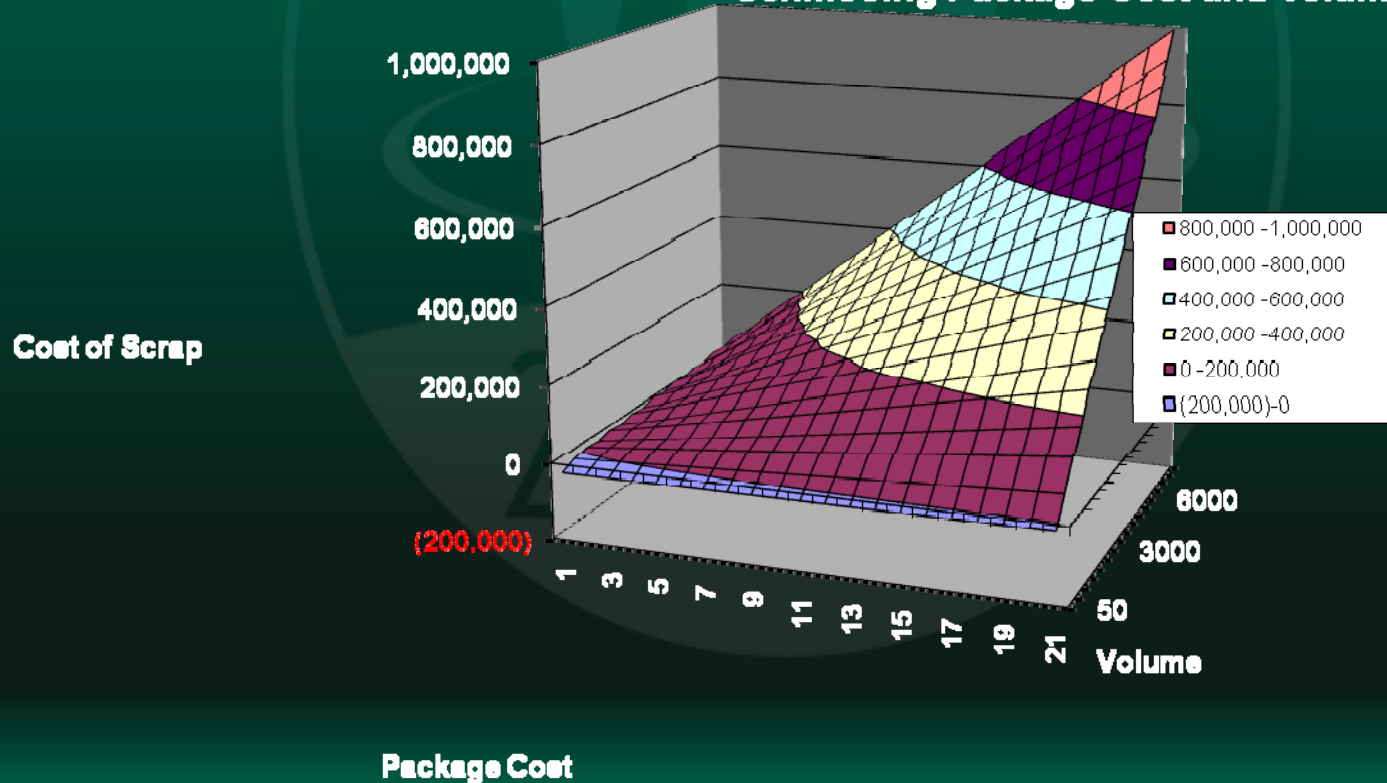
With > 0.5% yield improvement, MEMs provides cost savings at any wafer volume



Cost Model for ADC

At \$0.01 package cost MEMS provides cost benefits at >500 wafers

**Cost Model with fixed 2% Yield Improvement
using MEMS
Schmooling Package Cost and Volum**



Next Steps

- **Carry on to 1 million insertions or breaking point**
 - Compare to Cantilever life
- **Vary cleaning process to optimize cycles between cleaning**
 - By process
- **CRES Study with Higher current**
- **Release to High Volume Manufacturing**



Summary



MEMS Probes Support

- **MEMS probes enable full electrical test at Wafer sort**
 - Better FT yields and less scrap
 - Initial product showed 6% FT yield improvement
- **Supports MCM, and SIP programs**
 - Testing Everything at Wafer Sort improves module yields
- **Improve Known Good Die Test capability and sales**
- **EZ Implementation in manufacturing**
- **High Current Capable over 650ma per pin**
- **High Speed capable over 1.6ghz test limited by product**



Acknowledgements

- Dale Anderson
- Jessica Nguyen
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